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Dated: March 5, 2007

Signature:

(Arnold H. Krumholz)

Docket No.: AWA 3.3-006  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Patent Application of:**  
Jager et al.

**Application No.:** 10/553,447

**Group Art Unit:** 1775

**Filing Date:** October 26, 2006

**Examiner:** Not Yet  
Assigned

**For: METHOD FOR PRODUCING A  
MICROMACHINED LAYERED DEVICE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

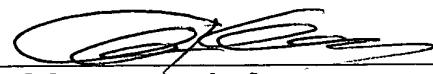
Dear Sir:

It is respectfully requested that the references listed on the enclosed Form PTO-1449 be made of record and considered with respect to the above-referenced U.S. patent application. A copy of each reference is enclosed. These references were cited in the background section of the present specification. Submission of the present Information Disclosure Statement should not be taken as an admission that the cited references are legally available prior art or that the same are pertinent or material.

In the event that any fee is due in connection with the present Information Disclosure Statement, the Commissioner is hereby authorized to charge the same to our Deposit Account No. 12-1095.

Dated: March 5, 2007

Respectfully submitted,

By   
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Substitute for form 1449/PTO				<i>Complete if Known</i>	
				Application Number	10/553,447-Conf. #1478
				Filing Date	October 26, 2006
				First Named Inventor	Edwin Jager
				Art Unit	1775
				Examiner Name	Not Yet Assigned
Sheet	1	of	1	Attorney Docket Number	AWA 3.3-006

<b>U.S. PATENT DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)	MM-DD-YYYY		

<b>FOREIGN PATENT DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	MM-DD-YYYY		

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<b>NON PATENT LITERATURE DOCUMENTS</b>					
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
	CA	KOVAS et al., "Silicon Micromachining: Sensors to Systems", Analytical Chemistry, Vol. 68, pgs. 407A-412A, July 1, 1996			
	CB	SMELA, "Microfabrication of PPy microactuators and other conjugated polymer devices", J. Micromech. Microeng., Vol. 9, No. 1, pgs. 1-18, 1999, IOP Publishing Ltd.			

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